

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Application Information

Application Type:: Divisional
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER
Attorney Docket Number:: 109725.01
Total Drawing Sheets:: 4
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hiroji
Family Name:: AGA
City of Residence:: Gunma
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Naoto
Family Name:: TATE
City of Residence:: Gunma
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Susumu
Family Name:: KAWABARA
City of Residence:: Gunma
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Kiyoshi
Family Name:: MITANI
City of Residence:: Gunma
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	Division of	09/857,803	06/11/2001
Which is a	National Stage of	PCT/JP00/07111	10/13/2000
Assignee Information			
Assignee Name::	Shin-Etsu Handotai Co., Ltd.		
Street of mailing address::	4-2 Marunouchi 1-chome, Chiyoda-ku		
City of mailing address::	Tokyo		
Country of mailing address::	Japan		